

**Response under 37 C.F.R. § 1.116  
Expedited Procedure  
Examining Group 2855**

PATENT  
ATTORNEY DOCKET: 46884-5345



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)	
	)	
Satoshi MATSUMOTO et al.	)	Confirmation No.: 8192
	)	
Application No.: 10/518,392	)	Group Art Unit: 2855
	)	
Filed: July 25, 2005	)	Examiner: Gail K. Verbitsky
	)	
For: LASER PROCESSING APPARATUS,	)	
LASER PROCESSING	)	
TEMPERATURE MEASURING	)	
APPARATUS, LASER	)	
PROCESSING METHOD, AND	)	
LASER PROCESSING	)	
TEMPERATURE MEASURING	)	
METHOD	)	

Commissioner for Patents  
U.S. Patent and Trademark Office  
**Customer Window, Mail Stop AF**  
Alexandria, VA 22314

Sir:

**AMENDMENT UNDER 37 C.F.R. § 1.116**

In response to the Final Office Action dated April 3, 2008, the period for response to which runs through October 3, 2008, by the concurrently-filed petition for a three-month extension of time and corresponding fee payment, entry of the following amendments is respectfully requested to place the application in clear condition for allowance or, alternatively, in better form for appeal: